

53RD IEEE INTERNATIONAL CONFERENCE ON PLASMA SCIENCE (ICOPS)

General Chair: Michael Murillo, University of Michigan

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Technical Program Chair: Lorin Matthews, *Baylor University*

Finance Chair: Peng Zhang, Michigan State University

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TOPICS

- Basic Processes in Fully and Partially Ionized Plasmas
- Microwave Generation and Plasma Interactions
- Charged Particle Beams and Sources
- High Energy Density Plasmas and Applications
- Industrial, Commercial and Medical Plasma Applications
- Plasma Diagnostics
- Pulsed Power and Other Plasma Applications

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